

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor : Yasushi HAYASHIDA, et al. CONF. NO.: 4274
U.S. Serial No. : 10/551,225
Group Art Unit : 3651 OK TO ENTER: /R.P./
Filed : September 28, 2005
Examiner : Ramya G. Prakasam
For : SUBSTRATED PROCESSING SYSTEM, AND METHOD OF
CONTROL THEREFOR, CONTROL PROGRAM, AND
STORAGE MEDIUM

AMENDMENT PURSUANT TO RULE 116

MAILSTOP: AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action mailed October 14, 2009, to which a response is due January 14, 2010, please amend the above-identified application as set forth below and consider the following remarks.

Amendments to the Claims begin on page 2.

Remarks begin on page 4.